

PATENT APPLICATION
Docket No.: 4591-366
Client Ref. No.: IC12242-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jeong-Min CHOI, et al.

Serial No.: 10/750,983 Examiner: Erdem, Fazli
Filed: January 2, 2004 Group Art Unit: 2826
Confirmation No.: 5470
For: SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND
METHOD OF FABRICATING THE SAME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Responsive to the Office Action, Paper No. 11122006, dated November 17, 2006, please amend the application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

An **Appendix** including a certified English translation of the priority document is attached following page 7 of this paper.